



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
DALE ET AL.)	
Serial No. 10/540,730)	Art Unit:
Filed: June 24, 2005)	Examiner:
For: COATINGS)	

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Respectfully submitted,

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Zara A. Doddridge, Ph.D. Limited Recognition No. L0030

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Our Docket: 46309-315846

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Complete if Known			
Application Number	10/540,730		
Filing Date	06-24-2005		
First Named Inventor	Nicholas Dale		
Art Unit			
Examiner Name			
Attorney Docket Number	46309-315846		

U.S. PATENT DOCUMENTS					
Examiner	Cite	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant
Initials *	No.1	Number - Kind Code ² (if known)	MM-DD-YYYY	Cited Document	Passages or Relevant Figures Appear
	1	US-5698083	12-16-1997	Robert S. Glass	
	2	US-6303290	10-16-2001	Liu et al.	

FOREIGN PATENT DOCUMENTS						
Examiner	Cite	Foreign Patent Document	Publication	Name of Patentee or	Pages, Columns, Lines,	
Initials*	No.1	Country Code ³ - Number ⁴ - Kind Code ⁵ (<i>if known</i>)	Date		Where Relevant Passages or Relevant Figures Appear	T⁵
	3	EP 0537761	04-21-1993	Yoshioka et al.		
	4	WO 99/07877	02-18-1999	Nicholas Dale		
	5	WO 99/10743	03-04-1999	Charych et al.		

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Examiner Initials	Cite No.1 Include name of the author (in CAPTIAL LETTERS), title of the article (when appropriate), title of the articl				
	6	ANGENENDT, PHILIPP ET AL.; "Toward optimized antibody microarrays: a comparison of current microarray support materials"; Analytical Biochemistry 309 (2002) 253-260			
	7	AVNIR, DAVID ET AL.; "Enzymes and Other Proteins Entrapped in Sol-Gel Materials"; Chem. Mater., Vol. 6, 1994, pp. 1605-1614			
	8	BOGART, K.H.A. ET AL.; "Surface reactivity measurements for OH radicals during deposition of SiO ₂ from tetraethoxysilane/ O ₂ plasmas,"; Chemical Physics Letters; 267 (1997); 377-383			
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	11	GHEORGHIES, C. ET AL.; "Forming of the Structure for the Thim Ceramic Films Prepared by the Electrolytical Method,"; Analele Stiintifice Ale Universitatii; 1999-2000; 268-275			
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	14	JONES, W.M. ET AL.; "Novel Processing of Silica Hydrosols and Gels,; Journal of Non-Crystalline Solids, 101; 1988; 123-126			

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Application Number 10/540,730
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STATEMENT BY APPLICANT First Named Inventor Nicholas Dale
Art Unit
(Use as many sheets as necessary) Examiner Name
Sheet 2 of 2 Attorney Docket Number 46309-315846

		OTHER INFORMATION - NON PATENT LITERATURE DOCUMENTS - (Continued)	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	15	LILLIS, B. ET AL.; "Investigation into immobilisation of lactate oxidase to improve stability," Sensors and Actuators B 68; 2000; 109-114	
	16	Extracts from Pamela M. Norns' online CV (University of Virginia, USA); "Production of Chromatographic Microchips using Sol-gel Derived Chromatographic Media" Funded by the Ivy Foundation, University of Virginia (PI: P.M. Norris, MAE; Co-PI: J. Landers, Chemistry)	
	17	PALMISANO, F. ET AL.; "Amperometric biosensors based on electrosynthesised polymeric films,: Fresenius J Analalytical Chemistry (2000) 366; 586-601	
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	23	YAN, D. ET AL.; 'Glycerated Bis-Silanes as Precursors for the Development of Sol-Gel Derived Biofilms,"; The 84 th Canadian Society for Chemistry Conference & Exhibition 2001	

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